



11th IMEKO Symposium
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Excellent Paper Award

presented to

Yuki Shimizu

for the paper

***DESIGN OF AN OPTICAL SYSTEM FOR
EVALUATION OF EDGE CONTOUR
OF A DIAMOND CUTTING TOOL***

Y Shimizu, S Jang and W Gao

September 4, 2014

Conference Chairs



Albert Weckenmann



Toshiyuki Takatsuji